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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Applicant

Yates, Donald L. et al.

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2812

U.S. PATENT DOCUMENTS

		Patent Number	Issue Date	Patentee	U.S. Class	Sub-Class	Filing Date
<i>an</i>	A1	H1,824	12-07-99	Johnsen et al.	427	255.6	08-01-97
<i>an</i>	A2	5,407,534	04-18-95	Thakur	156	662	12-10-93
<i>an</i>	A3	5,418,180	05-23-95	Brown	437	60	06-14-94
<i>an</i>	A4	5,616,959	04-01-97	Jeng	257	758	06-07-95
<i>an</i>	A5	6,022,595	02-08-00	McDonald et al.	427	497	01-31-97
<i>an</i>	A6	6,051,869	04-18-00	Pan et al.	257	506	12-18-98
<i>an</i>	A7	6,143,646	11-07-00	Wetzel	438	637	06-03-97
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<i>an</i>	A10	6,190,992	02-20-01	Sandhu et al.	438	398	07-15-96
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FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

Examiner Initial		Document Number	Publication Date	Country	Int'l Class	Sub-Class	Translation (Yes/No)
	B1						

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

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<i>an</i>	C1	Chan, Vanessa, et al., <i>Ordered Bicontinuous Nanoporous and Nanorelief Ceramic Films from Self-Assembling Polymer Precursors</i> , Science, November 26, 1999, Vol. 286, pp. 1716-1719
<i>an</i>	C2	Lewis, P.A., et al., <i>Silicon Nanopillars Formed with Gold Colloidal Particle Masking</i> , J. Vac. Sci. Technol., B 16(6), Nov/Dec 1998, pp. 2938-2941
<i>an</i>	C3	Phely-Bobin, et al., <i>Preferential Self-Assembly of Surface-Modified Si/SiO₂ Nanoparticles on UV/Ozone Micropatterned Poly(dimethylsiloxane) Films</i> , Adv. Mater., 2000, 12, No. 17, September 1, pp. 1257-1261
<i>an</i>	C4	Yang, G.R., et al., <i>Increase of Deposition Rate of Vapor Deposited Polymer by Electric Field</i> , DUMIC Conference, 1996 ISMIC, February 20-21, 1996, pp. 214-219
<i>a</i>	C5	Bromann, K., et al., <i>Self-Organized Growth of Cluster Arrays</i> , Eur. Phys. J. D, 9, 1999, pp. 25-28

Examiner Initials	<i>gcy</i>	Date Considered	10-9-03
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			